

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Eun Seog Lee :
Serial No: 09/890,253 : Art Unit #2173
Filed: 6 August 2001 : Examiner:
Title: DATA PROCESSING SYSTEM USING A : T. Hailu
DUAL MONITOR AND CONTROLLING
METHOD OF NETWORK SYSTEM THEREBY

AMENDMENT AFTER FINAL OFFICE ACTION

Mail Stop – AF
Honorable Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Responsive to the outstanding Official Action dated 11 July 2006, please
amend the above-referenced Patent Application as follows:

Amendments to the Claims are reflected in the Listing of Claims which
begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

Please ENTER
TH 10/5/06